

Application No.	Applicant(s)
10/073,600	GIRARD ET AL.
Examiner	Art Unit
Paul D. Kim	3729

SEARCHED				
Subclass	Date	Examiner		
603.07 603.1 603.12 603.16 851	2/5/2004	PK		
234.5 245.	2/6/2004	PK		
104 105	6/1/2005	PK		
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	Subclass 603.07 603.1 603.12 603.16 851 234.5 245.	Subclass Date 603.07 603.1 603.12 603.16 851 234.5 245. 104 604/2005		

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
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	CH NOTES ARCH STRATEGY)
	DATE	EXMR
Reviewed Parent Application 09/410,602 (ABN)	2/6/2004	PK
Consulted by Craig Renner (360)	2/6/2004	PK
Text Search EAST/NPL (IEEE)	2/6/2004	PK
Updated Text Search EAST	6/1/2005	PK
Updated Text Search EAST	3/9/2006	PK